

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1756
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77434

Tsutomu SHOKI, et al.

Appln. No.: 10/658,372

Group Art Unit: 1756

Confirmation No.: 3326

Examiner: John S. Ruggles

Filed: September 10, 2003

For: METHOD OF PRODUCING A REFLECTIVE-TYPE MASK BLANK, METHOD OF
PRODUCING A SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 22, 2006, please amend the above-identified application as follows on the accompanying pages.

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